

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Rule 53(b) Divisional Application of **10/315,929**:

**Naoya SASHIDA**

Group Art Unit: **2814 (expected)**

Serial No.: **(NEW)**

Examiner: **Hoai V. PHAM (expected)**

Filed: **October 31, 2003**

For: **SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME**

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 31, 2003

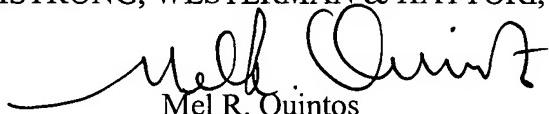
Sir:

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were made of record in parent application Serial No. **10/315,929**.

The Director is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449

**INFORMATION  
DISCLOSURE  
STATEMENT  
PTO-1449**

Atty. Docket No. 021557A	Serial No. New Divisional Appln.
Applicant(s): Naoya SASHIDA	
Filing Date: October 31, 2003	Group Art Unit: 2814 (expected)

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Subclas s	Filing Date (If appropriate)
_____	AA	2002/0006674 A1	Ma et al.	01/17/02	438	3	
_____	AB	6,570,203	Hikosaka et al.	05/2003	257	295	
_____	AC	6,171,970	Xing et al.	01/2001	438	706	
_____	AD						
_____	AE						
_____	AF						
_____	AG						
_____	AH						

**FOREIGN PATENT DOCUMENTS**

		Document No.	Date	Country	Translation (Yes or No)
_____	AI	2001-210798	08/03/01	Japan	Abstract
_____	AJ				
_____	AK				

**OTHER DOCUMENTS**

_____	AL	
_____	AM	
Examiner		Date Considered